

Polarized light-scattering measurements of dielectric spheres upon a silicon surface

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The polarization of light scattered into directions out of the plane of incidence by polystyrene latex spheres upon a silicon substrate was measured for *p*-polarized incident light. The experimental data show good agreement with theoretical predictions for three sizes of spheres. These results demonstrate that the polarization of light scattered by particles can be used to determine the size of particulate contaminants on silicon wafers. Theoretical models, based on successive degrees of approximation, indicate that the mean distance of a particle from the surface is the primary determinant of the scattered light polarization for small out-of-plane scattering angles.

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Detection and characterization of particles and defects on surfaces have been of great interest in the optical and semiconductor industries. Instruments based on light scattering satisfy many of the requirements of the industries, such as high throughput rate and high sensitivity. However, scattered light may arise from a number of sources, such as surface topography, surface residue, particulate contamination, and subsurface defects. Analyzing the scattered intensity to correctly determine the size, shape, and material of a contaminant is complicated. Recently Germer¹ and Germer and Asmail^{2,3} demonstrated experimentally and theoretically that the polarization of scattered light can be used to distinguish among various types of light-scattering features near surfaces. Using the unique polarization properties of each scatter source, one can separate the contributions from the various sources of scattering and improve the ability of optical inspection tools to detect particulate contamination and subsurface defects over a background dominated by substrate microroughness.

We present a model system containing accurately sized polystyrene latex (PSL) spheres upon a silicon surface to test theoretical models for scattering from particles above a surface. Numerous theories describing the light (of wavelength λ) scattered by a sphere of diameter D and complex refractive index n_{sph} above a smooth surface of complex refractive index n_s have been developed.^{1,4-8} In the Rayleigh approximation,^{1,6,7} which is valid for $D \ll \lambda$, the scatterer is treated as a point polarizable dipole. The particle is assumed to be illuminated by the incident light and by its reflection in the surface, and the induced dipole is assumed to radiate directly into the scattering hemisphere and through reflection in the surface. The key parameter in this approximation is the mean distance $d = D/2$ of the particle from the surface, which determines the interference between the different optical paths.

The PSL spheres that we used in this study are sufficiently large that the light scattered from an isolated sphere is not entirely Rayleigh-like. In the Mie-surface approximation (sometimes referred to as the double interaction model⁸) we include the field scattered by a homogeneous sphere, using the exact Mie solution⁹ for a sphere in free space. In both the Rayleigh and Mie-surface approximation we neglect the interaction between the particle and its image in the substrate. To account for this interaction, a discrete-dipole approximation (DDA) is used. In the DDA an object is built from a large number of interacting dipoles. The near-field interactions between successive dipoles, both directly and through their reflections in the surface, are included in the calculation. A self-consistent solution for all the dipoles is iteratively determined. A complete description of the DDA algorithm is given elsewhere.¹⁰ In all the approximations it is assumed that the spheres are isolated.

A low-pressure impactor connected to a particle generation-classification system was used to deposit monodisperse PSL spheres onto bare silicon wafers.^{11,12} Results for PSL spheres that had diameters of 100.7 ± 1.0 , 181.0 ± 6.0 , and 217.7 ± 3.4 nm (Refs. 12 and 13) and polydispersity of less than 2% are presented here. Using a dark-field reflection optical microscope, we estimated the number density of the samples that contained 181.0- and 217.7-nm spheres to be $\sim 0.03 \mu\text{m}^{-2}$ in the illuminated sample regions. Fewer than 2% of the particles were doublets. A field emission scanning-electron microscope indicated that $\sim 10\%$ of particles deposited upon the sample that contained 100.7-nm spheres were doublets and that the number density was $\sim 0.2 \mu\text{m}^{-2}$. The effect of the presence of doublets on the polarization of scattered light is discussed below.

Figure 1(a) shows the optical geometry used in this study. Laser light of wavelength $\lambda = 532$ nm is incident onto a sample (Gaussian beam diameter,

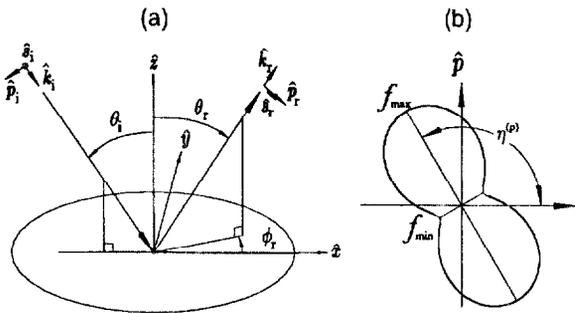


Fig. 1. (a) Optical geometry used in this Letter. (b) Schematic polar plot of the intensity distribution f measured by a rotating linear-polarization-sensitive detector defining the BE parameters $\eta^{(p)}$ and $P_L^{(p)} = (f_{\max} - f_{\min}) / (f_{\max} + f_{\min})$.

$2\omega_0 \approx 1$ mm) at an angle θ_i , and light scattered into a solid angle $\Omega \approx 10^{-4}$ sr centered on a polar angle θ_r and azimuthal (out-of-plane) angle ϕ_r is collected. Bidirectional ellipsometric (BE) measurements are presented in terms of the principal angle of polarization $\eta^{(p)}$ and the degree of linear polarization $P_L^{(p)}$ as functions of ϕ_r for fixed θ_i and θ_r for p -polarized incident light [see Fig. 1(b)]. The bidirectional reflectance distribution function levels in the $\theta_i = \theta_r = 45^\circ$ and $\phi_r = 90^\circ$ configuration were approximately 1×10^{-4} , 2×10^{-5} , 4×10^{-6} , and 1×10^{-7} sr $^{-1}$ for samples with 217.7-, 181.0-, and 100.7-nm spheres and for the bare silicon wafers before deposition, respectively.

Figures 2(a) and 2(b) compare the predictions of the three models for the BE parameters for two particle sizes, 100 and 200 nm. In all theoretical calculations performed in this study, we assume indices of refraction appropriate for $\lambda = 532$ nm: $n_{\text{sph}} = 1.59$ and $n_s = 4.15 + 0.05i$. By comparing the predictions of the three approximations, we can evaluate the contributions from the interference between the incident and the reflected beams (from the Rayleigh model), the finite size and the material of the sphere (from the differences between the Rayleigh and the Mie-surface models), and the near-field sphere-surface interaction (from the differences between the Mie-surface and DDA models). Note that the differences between the models become noticeable as the particle diameter increases. However, the predictions for $\eta^{(p)}$ at small ϕ_r (for $\phi_r \leq 60^\circ$) are relatively independent of the model. This finding indicates that the strongest determining factor of the parameter $\eta^{(p)}$ at small ϕ_r is the mean distance of the sphere from the surface and is not strongly affected by the material of the sphere.

It is evident that $\eta^{(p)}$ has a unique angular dependence for each particle size and that we can relate the slope of the $\eta^{(p)}$ -versus- ϕ_r curves near $\phi_r = 0$ to the particle size. Figure 2(c) shows $-\Delta\eta^{(p)}/\Delta\phi_r$, evaluated at $\phi_r = 0$, as a function of the diameter of the particle for the three different approximations. All three models predict similar behavior in the displayed region and converge to one another for small diameters. This result implies that the particle size can be estimated by the slope of $\eta^{(p)}$ in the small ϕ_r region or, more simply, by the value of $\eta^{(p)}$ at a small fixed ϕ_r . However, to determine the size of an arbitrary particle more

accurately and to obtain information about particle-substrate interaction, particle shape, or particle material we would need to measure the BE parameters for a wide range of ϕ_r and for different θ_i and θ_r . Because the DDA model is the most comprehensive model, we use it in the remainder of this Letter to compare to the experimental data. Experimental data obtained from three particle sizes are also shown in Fig. 2(c) and are discussed below.

Figure 3 shows the BE parameters for the sample with 181.0-nm PSL spheres as functions of ϕ_r for different values of $\theta_i = \theta_r$, together with the corresponding theoretical predictions of the DDA model. The experimental data are in good agreement with the theoretical predictions for all values of ϕ_r at all scattering conditions. A more detailed examination of the data

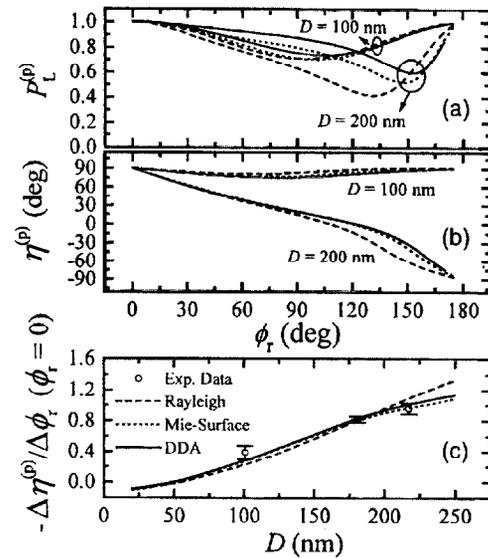


Fig. 2. (a), (b) Results of BE calculations in which three approximations are used for light scattering from two different diameters of PSL spheres above a smooth silicon surface for $\lambda = 532$ nm at $\theta_i = \theta_r = 45^\circ$. (c) The slope, $-\Delta\eta^{(p)}/\Delta\phi_r$ ($\phi_r \rightarrow 0$), as a function of D for three theoretical approximations with experimental results.

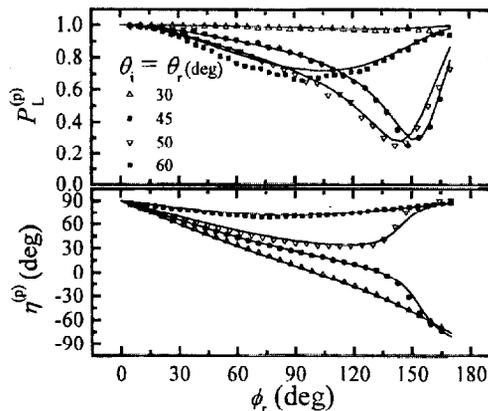


Fig. 3. BE parameters for 181.0-nm PSL spheres upon silicon at different incident and scattering angles. The curves represent the predictions of the DDA model. The uncertainties in the data are smaller than or approximately the same size as the symbols.

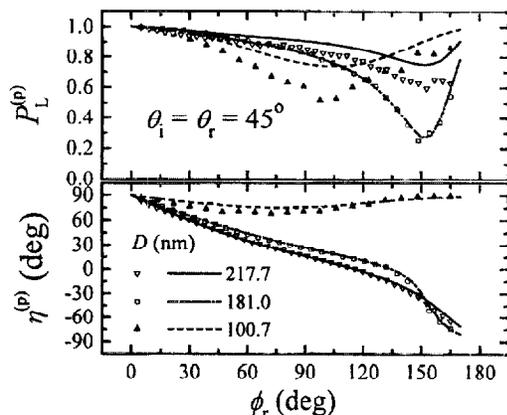


Fig. 4. Same as Fig. 3 except for three PSL sphere sizes at $\theta_i = \theta_r = 45^\circ$.

indicates that there is a slight deviation for large θ_i or θ_r . The differences between the data and the theory for large θ_i or θ_r may be due to contributions from interactions between particles, to the presence of nonspherical particles on the surface, or to interference with other scattering sources. Random sources of scatter, such as these, are expected to depolarize the light.

Figure 4 shows the BE results at $\theta_i = \theta_r = 45^\circ$ for samples with three different diameters. The DDA model predicts the overall trend of the angular dependence of the BE parameters for particles with different diameters. The agreement between the measured polarization angles $\eta^{(p)}$ and those predicted by the theory for a 217.7-nm PSL sphere is excellent. However, the corresponding values of measured $P_L^{(p)}$ are smaller than those predicted by the theory at large scattering angles. Again, the increasing depolarization of light may be due to the causes that we mentioned above. The results in Fig. 4 imply that we can determine the size of the spheres by using BE measurements. We also extracted the values of $-\Delta\eta^{(p)}/\Delta\phi_r(\phi_r \rightarrow 0)$ and present the results with the theoretical predictions in Fig. 2(c). The uncertainties of $-\Delta\eta^{(p)}/\Delta\phi_r$ were evaluated by a standard statistical data analysis from the linear regression of the first few data in the $\eta^{(p)}$ -versus- ϕ_r plot [see Fig. 2(c)] and represent 95% confidence levels. The results in Fig. 2(c) suggest that we can use BE data in small out-of-plane scattering angles to estimate the size of unknown spheres.

Although the agreement between theory and experimental data in Figs. 2(c) and 4 is good for the 181.0- and 217.7-nm spheres, it is not so good for the 100.7-nm spheres. The discrepancies between the data and the-

ory for the sample that contains 100.7-nm PSL spheres are probably due to contributions from doublets. We calculated the BE parameters for systems with two touching 100.7-nm spheres aligned along the \hat{x} , \hat{y} , and \hat{z} directions. We found that $-\Delta\eta^{(p)}/\Delta\phi_r$ for these systems is approximately 1.1, 2.3, and 2.8 times larger, respectively, than that from a system with a single sphere. Without accurate information about the density and geometrical configurations of the doublets it is difficult to refine the model further to account for the presence of doublets. Further research will be carried out to reduce the fraction of such doublets.

In summary, BE measurements of a model system that contained accurately sized PSL spheres upon silicon were made and compared with a DDA model for a sphere above a smooth surface. This study demonstrates that the polarization of light scattered by particles can be used to determine the size of particulate contaminants on a smooth surface.

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